VERSION WITH MARKINGS TO SHOW CHANGES MADE

16. (Amended) The apparatus of claim [16] 91, wherein the flexure comprises a plurality of torsion beams.

17. (Amended) A method, comprising:

forming a gap having a distance between a first blade and a second blade;

applying an electrostatic potential between the first blade and the second blade to generate a [force] torque to move the first blade relative to the second blade along a rotational range of motion; and

maintaining the distance of the gap between the first and second blades through the rotational range of motion.

18. (Amended) The method of claim 17, further comprising adjusting the [force] torque along the range of motion.

19. (Amended) The method of claim 18, wherein the adjustment of the [force] torque is maintained approximately [linear] constant along the range of motion.

27. (Amended) The apparatus of claim 26, wherein the first blade is configured to move relative to the second blade along a range and wherein the distance between the first blade and the second blade is maintained substantially [parallel] constant throughout the range of motion.

28. (Amended) The apparatus of claim 23, wherein the movable frame is pivotally coupled [to] using the first plurality of torsion beams.

32. (Amended) The apparatus of claim 23 [13], wherein the first flexure comprises a pair of torsion beams.

34. (Amended) The apparatus claim 23 [13], wherein the second flexure comprises a pair of torsion beams, each of the torsion beams having a length and wherein the torsion beams are non-parallel along a portion of their lengths.

45. (Amended) An apparatus, comprising:

a plurality of actuators, each of the plurality of actuators comprising:

a central stage;

a movable frame disposed around the central stage;

a first blade coupled to the central stage perpendicular to the surface of the central stage; and

a second blade coupled to the movable frame perpendicular to the surface of the movable frame, the second blade being parallel with the first blade; and

a fixed frame disposed around each [the] movable frame of the plurality of actuators.

48. (Amended) The method of claim 47, further comprising attaching a protective structure to the second side of the substrate prior to etching [through the second trenches] to release the structures.

65. (Amended) The method of claim [56] 58, wherein the protective lid comprises glass.

67. (Amended) The method of claim 66, further comprising attaching a protective structure to the second side of the SOI substrate prior to etching [through the trenches] to release the structures.

76. (Amended) The method of claim 75, further comprising attaching a base substrate to the spacer substrate prior to etching [through the second trenches] to release the structures.

New Claims 84-119 have been added.